

Search Notes	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/762,210	BERENSON ET AL.
	Examiner	Art Unit
	Taeyoon Kim	1651

SEARCHED

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
435	375	6/2/2008	TK
435	325	6/2/2008	TK
435	372.3	6/2/2008	TK

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**